

SCIENTIFIC REPORTS



OPEN

Efficient Terahertz detection in black-phosphorus nano-transistors with selective and controllable plasma-wave, bolometric and thermoelectric response

Leonardo Viti¹, Jin Hu², Dominique Coquillat³, Antonio Politano⁴, Wojciech Knap^{3,5} & Miriam S. Vitiello¹

The ability to convert light into an electrical signal with high efficiencies and controllable dynamics, is a major need in photonics and optoelectronics. In the Terahertz (THz) frequency range, with its exceptional application possibilities in high data rate wireless communications, security, night-vision, biomedical or video-imaging and gas sensing, detection technologies providing efficiency and sensitivity performances that can be “engineered” from scratch, remain elusive. Here, by exploiting the inherent electrical and thermal in-plane anisotropy of a flexible thin flake of black-phosphorus (BP), we devise plasma-wave, thermoelectric and bolometric nano-detectors with a selective, switchable and controllable operating mechanism. All devices operate at room-temperature and are integrated on-chip with planar nanoantennas, which provide remarkable efficiencies through light-harvesting in the strongly sub-wavelength device channel. The achieved selective detection ($\sim 5\text{--}8\text{ V/W}$ responsivity) and sensitivity performances (signal-to-noise ratio of 500), are here exploited to demonstrate the first concrete application of a phosphorus-based active THz device, for pharmaceutical and quality control imaging of macroscopic samples, in real-time and in a realistic setting.

Two-dimensional (2D) van der Waals layered materials^{1,2} display an extraordinary technological potential for engineering nano-electronic and nano-photonics devices and components; they also provide an intriguing platform for fundamental investigations, through the exploitation of their confined electronic systems. If placed on chip with flat integrated optical circuits³, they can allow maximal interaction with light, therefore optimally utilizing their novel and versatile properties for a large number of applications in optical communications⁴, spintronics⁵, high-resolution sensing⁶ and tomography. Amongst the growing scale of required capabilities, the need for a photo-detection platform combining high speed, efficiency, wavelength range, flexibility, and integrability with more conventional semiconductor-based technologies is becoming more eminent^{7,8}.

In the last few years, graphene and related materials have rapidly established themselves as intriguing building blocks for devising photo-detectors⁷: graphene exhibits ultrafast carrier dynamics, wavelength-independent absorption, tunable optical properties via electrostatic doping and high-mobility, which enables ultrafast conversion of photons or plasmons to electrical currents or voltages⁹. As a major distinctive characteristic, graphene is gapless, allowing charge carrier generation by light absorption over a very wide energy spectrum, while always conducting a significant amount of electricity. This inherent “leakage” can however significantly affect the efficiency of graphene-based devices.

¹NEST, Istituto Nanoscienze – CNR and Scuola Normale Superiore, Piazza San Silvestro 12, Pisa, I-56127.

²Department of Physics and Engineering Physics, Tulane University, New Orleans, LA-70118, USA. ³Laboratoire Charles Coulomb (L2C), UMR 5221 CNRS-Université de Montpellier, Montpellier, France. ⁴Università degli Studi della Calabria, Dipartimento di Fisica, via Ponte Bucci, 87036 Rende (CS), Italy. ⁵Institute of High Pressure Institute Physics Polish Academy of Sciences Warsaw Poland. Correspondence and requests for materials should be addressed to M.S.V. (email: miriam.vitiello@sns.it)

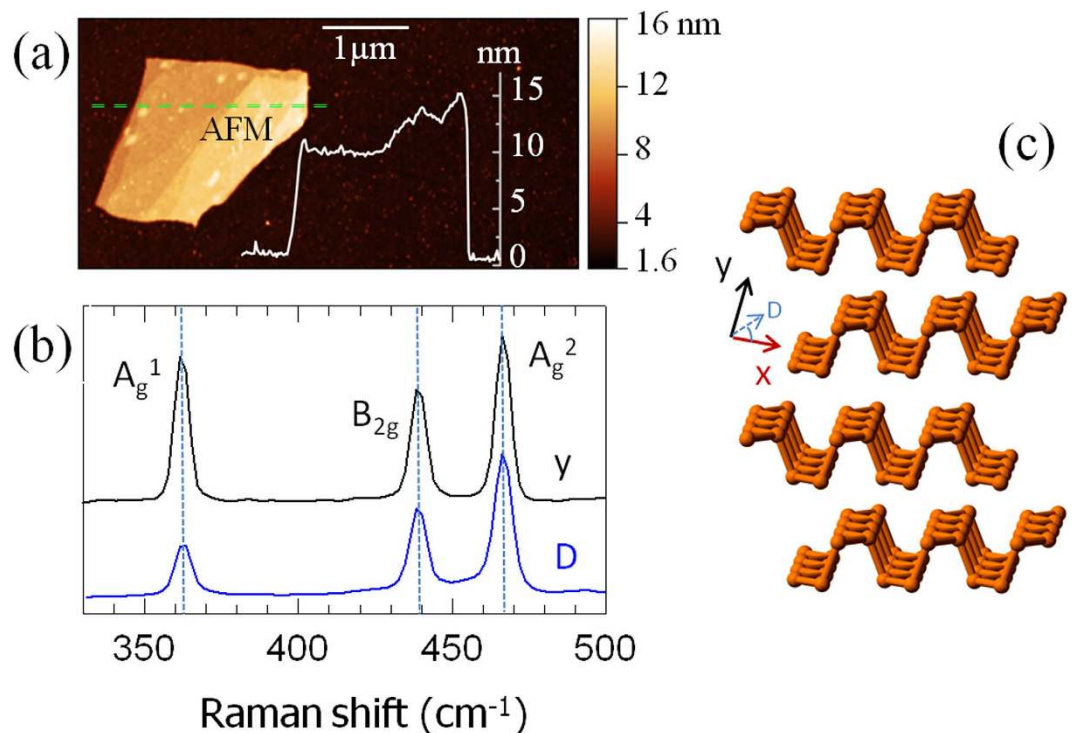


Figure 1. Flake identification and characterization. (a) Atomic force microscopy topographic image of an individual flake with thickness 15 nm. A topographic line profile, acquired along the dashed green line is shown. (b) Micro-Raman spectrum collected by exciting the samples along the z axis with the 532 nm line of a Nd-Yag pumping laser and by varying the polarization between the zigzag (y) and the 45° orientation angle (D axis) between the armchair (x) and y axis. Peaks are found at 362, 440, and 468 cm^{-1} , corresponding to the A_g^1 , B_{2g} , and A_g^2 vibrational modes, respectively. (c) BP atoms are arranged in puckered honeycomb layers bounded together by Van der Waals forces; the armchair (x) and zigzag (y) crystal axis are shown on the graph.

Layered 2D materials with a band gap have recently triggered an increasing scientific interest^{7,10}. Behaving like semiconductors, they only conduct electricity whenever the electrons absorb enough energy through heat, light, and other means. Depending on their specific band structures, these materials can disclose peculiar functionalities to be exploited for highly efficient light detection. With an energy gap in-between the gapless graphene and the larger gap transition-metal dichalcogenides, black phosphorus (BP) recently emerged as a fascinating and versatile material for photo-detection^{3,11}.

BP is composed of stacks of its monolayer structure, phosphorene, along the z axis. Its band gap can be engineered and tuned by varying the number of layers stacked together¹². Additionally, BP is a “direct-bandgap” semiconductor, meaning that it has the potential to efficiently convert electrical signals back into light. Unlike layered crystals with flat in-plane lattice, the BP monolayer, puckered along the armchair (x) direction, creates a fully anisotropic band structure that reflects in a large electrical, thermal and visible/near IR-optical in-plane anisotropy^{12–15}. As a result, being an intrinsically flexible material that converts heat in energy with high efficiency and with performances that do not require any sophisticated engineering, BP can effectively provide new functionalities in a variety of device applications.

Despite the recent demonstration of high-performance waveguide-integrated³ or junction-based BP photo-detectors at telecom and mid-infrared frequencies^{11,16,17}, the exploitation of BP for light detection at THz-frequencies is still at its early stage¹⁸, although the inherent material anisotropy can be appealingly exploited to devise detector architectures in which the photo-detection mechanism can be completely “designed”.

Photodetection of light, i.e. conversion of photons into a stable electrical signal, at THz frequencies can be accomplished by several different mechanisms like photo-thermoelectric, photovoltaic, galvanic, bolometric, plasma-wave rectification or via a combination of them^{7,19}. Here, we engineer the architecture of antenna-coupled THz nanodetectors exploiting thin flakes of exfoliated BP, to selectively activate each of those processes, individually. The inherent electrical and thermal in-plane anisotropy of BP is exploited to selectively control the detection dynamics in the BP channel, at room-temperature (RT) and with state-of-the-art detection efficiency.

Results and Discussion

Single-crystalline ingots of BP were grown via a chemical vapor transport technique similar to the one reported in ref. 20 (see Methods). Flakes having thickness in the range 8–14 nm were then mechanically exfoliated from bulk BP crystal using a standard adhesive tape technique on a 300 nm thick SiO_2 layer on the top of a 300 μm-thick intrinsic silicon wafer. The exfoliated flakes were initially identified via optical and scanning electron microscopy (SEM) and then characterized with atomic force microscopy (AFM), Fig. 1(a), and linearly polarized

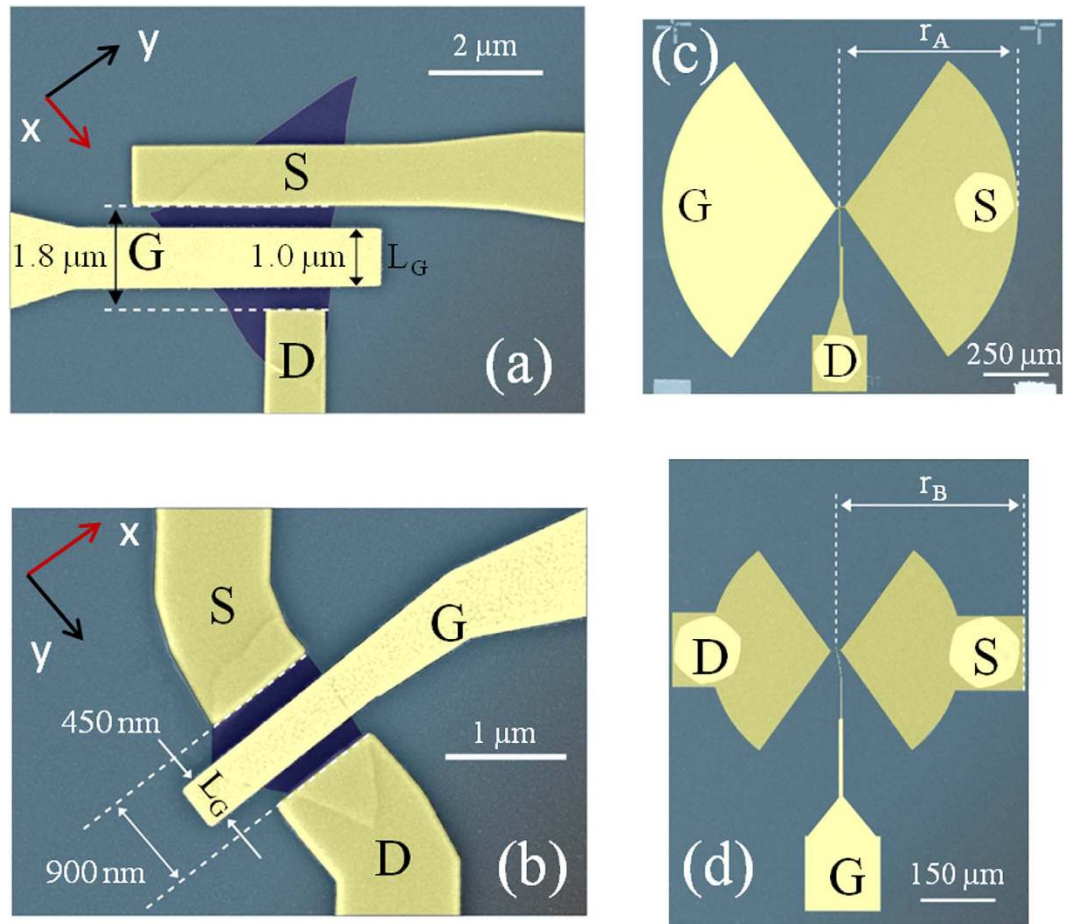


Figure 2. Device Fabrication. (a,b) False colors scanning electron microscope (SEM) images of the top-gated FETs in sample A (a) and sample B (b), respectively. (c,d) False colors SEM images of the patterned bow-tie antennas in sample A ($r_A = 0.5$ mm) and sample B ($r_B = 0.25$ mm), respectively.

micro-Raman spectroscopy, Fig. 1(b), to determine the layer thickness and the crystallographic directions, respectively (see Fig. 1(c) and Methods). Thin flakes with thicknesses $h \sim 9$ nm (corresponding to ~ 15 layers) and $h \sim 14$ nm (~ 23 layers) were individually contacted with proper adhesion layer/metal sequences to define the source (S) and drain (D) electrodes of a field effect transistor (FET) via aligned electron beam lithography (EBL) (see Methods). We fabricated two sets of samples: in sample A (23 layers) the S-D channel was defined along the D axis (see Fig. 1c), i.e. at a 45° angle in-between the armchair (x) and zigzag (y) directions; in sample B (15 layers) the S-D channel was conversely defined along the y -axis. Micro-Raman spectra shown in Fig. 1(b) (see Methods) provide clear indication of the channel orientation through the intensity ratio of the A_g^2 and A_g^1 active modes¹³.

In sample A, the S and gate (G) electrodes were then patterned in the shape of a half 110° bow-tie antenna, introducing a strong asymmetry in the mechanism of light harvesting; conversely, in sample B, a 110° bow-tie antenna was symmetrically placed at the S and D electrodes. In both cases, the antenna is designed to have maximum/resonant efficiency at 0.29 THz. The scanning electron microscopy (SEM) images of the device are shown in Fig. 2(a–d). The ratio between the channel length L and the gate length L_G was kept ≤ 2 , to reduce the portion of ungated channel regions as well as the related resistances and the parasitic capacitances.

Figure 3(a–b) shows the transconductance characteristics of sample A [Fig. 3(a)] and B [Fig. 3(b)] measured while maintaining the gate bias (V_G) below the breakdown voltage of the top-gate oxide (≈ 12 V for sputtered SiO_2), and when the 0.29 THz beam of a tunable electronic source operating in the 0.265–0.375 THz range, was impinging on the device ($I_{SD, \text{on}}$) or when it was blanked ($I_{SD, \text{off}}$). All measurements have been performed along an identical gate-bias sweep direction, to rule out any possible hysteresis-related effect. The analysis of the transfer characteristics shows that the maximum device transconductance (g_m) is partially affected by the BP flake orientation. Indeed, while the THz beam is blanked $g_m = 9.1$ nA/V in sample A and $g_m = 19.0$ nA/V in sample B. Conversely, when the THz light is funneled on the BP channel, g_m remains unchanged in sample A and decreases up to 11.5 nA/V in sample B, indicating a different detection mechanism. The analysis of the logarithmic plot of the transconductance curves also clearly unveils a large difference in the subthreshold slopes (S_s)⁻¹ which approach $S_s = 238$ mV/dec and $S_s = 1136$ mV/dec, for sample A and B (see Methods)¹⁸. The transconductance characteristics also provide a valuable way to extrapolate the carrier density (n) and the mobility (μ_{FE}) through the relations $n = C_{gc} V_{th} / (e \cdot h \cdot A_G)$ and $\mu_{FE} = g_m L_G^2 / (C_{TG} V_{SD})$, where A_G is the gated area and C_{TG} the total top-gate capacitance (see Methods). We extracted $n \sim 8.0 \times 10^{18} \text{ cm}^{-3}$ and $n \sim 2.2 \times 10^{19} \text{ cm}^{-3}$ for sample

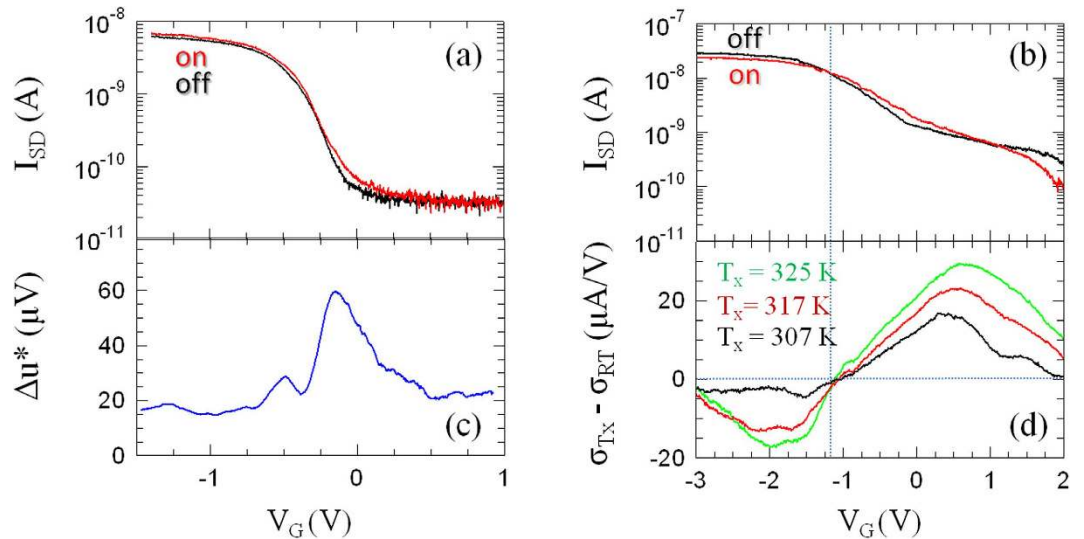


Figure 3. Transport characteristics. (a,b) Room-temperature (RT) transfer characteristics of sample A (a) and B (b) measured while sweeping V_G , by keeping $V_{SD} = 0.2$ mV and while a 0.29 THz beam was impinging on the device ($I_{SD,on}$) or when it was blanked ($I_{SD,off}$). I_{SD} was amplified by a factor 10^6 by using a transimpedance amplifier. (c) dc photovoltage trend vs V_G , measured from the difference between the $I_{SD,on}$ and $I_{SD,off}$, multiplied by the channel resistance. (d) Gate voltage dependence of the difference between the RT conductance and the conductance measured at T_x , in the three different cases in which $T_x = 307$ K, 317 K, 325 K. The dashed vertical line identifies the transition between the regime in which $\gamma = d\sigma/dT < 0$ (degenerate semiconductor) and $\gamma > 0$ (non-degenerate semiconductor).

A and B, respectively. The mobility value is unaffected by the impinging THz light for sample A ($\mu \approx 330$ cm²/Vs). Conversely, a 30% THz light-induced carrier mobility reduction was found in sample B ($\mu \approx 380$ –540 cm²/Vs).

In sample A, $I_{SD,on}$ remains larger than the $I_{SD,off}$ in the whole gate bias range, Fig. 3(a). The comparison between the two curves allows evaluating the dc photovoltage value [Fig. 3(c)] extracted from the measured photocurrent and labeled as $\Delta u^* = (I_{SD,on} - I_{SD,off})\sigma^{-1} = \Delta I \times \sigma^{-1}$ via the measurement of the overall channel conductance σ (extracted from Fig. 3a at device on), that provides a valuable way to predict the trend of the optical responsivity (R_x) and ac photovoltage (Δu). It is worth mentioning that Δu^* is however much less influenced by the loading than the photovoltage, being a purely dc measurement, not affected by the device capacitive reactance.

Conversely, sample B shows a peculiar V_G -dependence of $I_{SD,on}$ (Fig. 3b): for $V_G < -1.1$ V, $I_{SD,on} < I_{SD,off}$, then in the range $-1.1 < V_G < 1$ V, $I_{SD,on} > I_{SD,off}$ and finally at $V_G > 1$, $I_{SD,on}$ decreases below $I_{SD,off}$, indicating three distinctive physical regimes. To better elucidate the nature of this behavior, we measured the conductance of sample B at three distinct temperatures T_x , while heating it with an electric hot air gun and monitoring its temperature using a silicon diode thermometer in close contact with it. Figure 3(d) shows the voltage dependence of the difference between the RT conductance and the conductance measured at T_x , in the three different cases in which $T_x = 307$ K, 317 K and 325 K. The plot clearly shows that the parameter $\gamma = d\sigma/dT$, which defines the bolometric coefficient, changes sign in correspondence of the first sign switch between $I_{SD,on}$ and $I_{SD,off}$ marked in Fig. 3(b). This means that BP behaves like a degenerate ($\gamma < 0$) and non-degenerate ($\gamma > 0$) semiconductor along its transconductance curve. Conversely, the sign switch at $V_G = 1$ V [Fig. 3(b)], not unveiled in the temperature-dependent plots of Fig. 3(d), can be likely ascribed to the THz-light induced voltage imbalance between the two antenna lobes, which adds to the static applied voltage $V_{SD} = 0.2$ mV.

Figures 4(a,b) show the responsivity/photovoltage trends plotted as a function of V_G and measured, via a lock-in acquisition technique (see Methods), when a 0.29 THz beam was impinging on device A and B, respectively, with $V_{SD} = 0$ V.

In the case of fully asymmetric FET architectures, as in the case of sample A, two main effects are expected to be triggered by the incoming THz radiation: (i) the excitation of plasma oscillations along the FET channel^{21,22}; (ii) the heating of the metallic contacts due to the THz-driven local currents inside the antenna arms²³. By contrast, symmetric geometries, like the one employed for sample B, can likely induce bolometric detection effects, under specific material/geometry configurations. Both plasma-wave and thermoelectric effects are conversely prevented by the inherent symmetry.

The plasma-wave rectification effect, triggered by the antenna asymmetric radiation feeding in the conductive channel, results in an asymmetric charge density modulation, which will in turn induce a longitudinal electric field, with a preferential direction for the current flow. Under this regime (diffusive overdamped plasma-wave self-mixing regime), the generated photoresponse can be deduced from the transfer characteristics of the FET via the relation^{21,22,24},

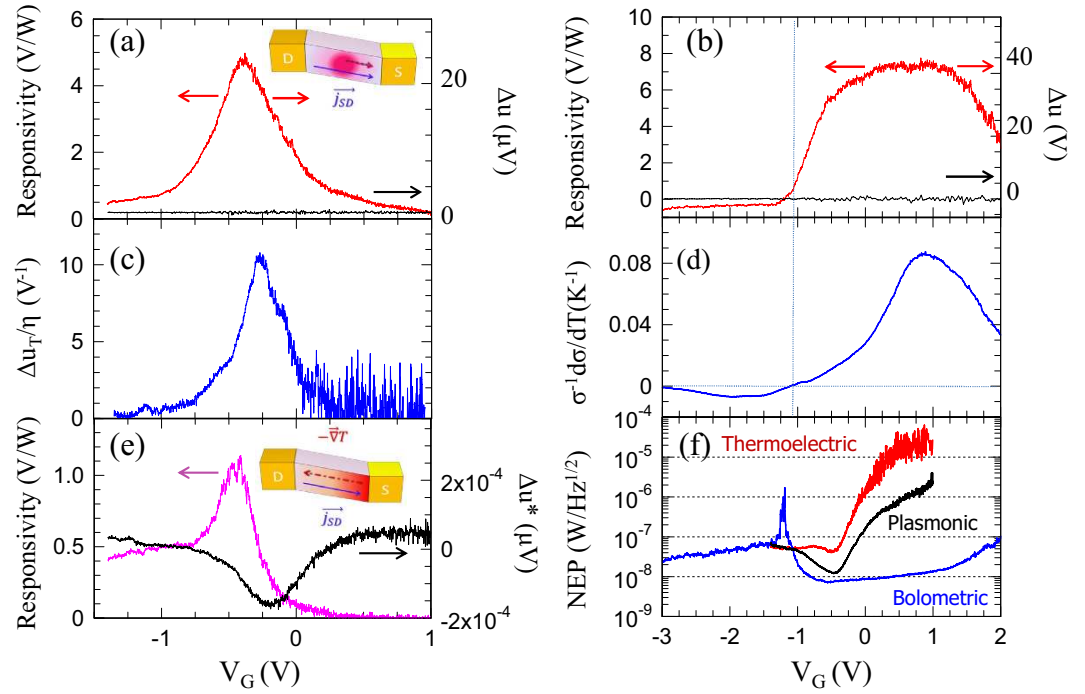


Figure 4. Terahertz detection. (a,b) Gate-bias dependence of the experimental RT responsivity (R_v)/ photovoltage (Δu) for sample A (a) and B (b). The red lines were measured by impinging the 0.29 THz beam on the detectors surface; the black lines were collected while blanking the beam with an absorber. Inset: schematics of the overdamped plasma-wave dynamics. (c) Predicted photoresponse of sample A as a function of V_G , under the overdamped plasma-wave regime. (d) Predicted bolometric trend, estimated from the gate voltage dependence of the ratio $\sigma^{-1}d\sigma/dV_G$ for sample B. (e) Left vertical axis: Gate bias dependence of the experimental RT responsivity of sample A collected while funneling the antenna resonant-frequency detuned 0.32 THz beam on the FET channel. Right vertical axis: dc photovoltage trend vs V_G , measured from the difference between the $I_{SD,on}$ and $I_{SD,off}$, multiplied by the channel resistance. Inset: schematics of the thermoelectric dynamics (f) Noise equivalent power (NEP) as a function of V_G , for the plasma-wave (sample A, 0.29 THz), thermoelectric (sample A, 0.32 THz) and bolometric (sample B) detectors extracted from the ratio between the thermal noise spectral density $N_{th} = (4k_B T \sigma^{-1})^{1/2}$ and the device responsivity.

$$\Delta u_T = -\frac{1}{\sigma} \cdot \frac{d\sigma}{dV_G} \cdot \left[\frac{R_L}{\frac{1}{\sigma} + R_L} \right] \cdot \eta \tag{1}$$

where R_L is the finite impedance of the measurement setup including the readout circuitry and the constant η represents the antenna-dependent coupling efficiency.

Equation (1), applied to the plot in Fig. 3(a), results in the predicted photovoltage trend shown in Fig. 4(c). The comparison with the corresponding experimental Δu curve [Fig. 4(a), right vertical axis], shows good agreement: R_v peaks at negative V_G without any sign switch, as expected, and in full agreement with the predicted behavior.

Whenever a 2D semiconductor is non-uniformly heated, its thermal and electrical properties are locally modified and a steady state current density (I_T) can be generated. The latter can be expressed as in ref. 19:

$$I_T = \sigma V_{DS} + \int_0^L \sigma S_b(x) \frac{dT_{el}}{dx} dx - \int_0^L e \mu n^*(x) \frac{dV(x)}{dx} dx + \int_0^L \gamma [T_{ph} - T_0] \frac{dV(x)}{dx} dx \tag{2}$$

The first term is the steady-state dc current driven by the applied drain-to-source bias V_{SD} ; the second term is the photothermoelectric current (I_{pe}) generated either by a temperature gradient within a non-zero Seebeck coefficient (S_b) homogeneous material or by the electrical contact between two materials with different S_b (thermocouple junction)^{14,22}; the third term is the photovoltaic contribution (I_{pv}) induced by the excitation of carriers from the valence to the conduction band via interband transitions excited by the absorption of photons, (n^* is the density of photo-excited carriers); the last term takes into account the bolometric contribution (I_b) to the current driven by the thermal excitation of the lattice (T_{ph} is the phonon temperature) that modifies the conductivity of the material through the bolometric coefficient γ , which depends from the strength of the electron-phonon coupling. The derivative $dV(x)/dx$ here represents a static collection bias along the channel.

In the present case, by keeping in mind that the THz optical power is effectively transferred to the flake by the antenna, the following considerations can be done: i) the first term in (2) contributes to the dark current and it is negligible in our case, being $V_{SD} = 0$ V; ii) I_{pe} can play a role only for sample A; no temperature gradient is

indeed present along the FET channel of sample B, as an effect of both the symmetric radiation feeding and the reduced distances between the metallic electrodes (heat-sink). Moreover, the thermoelectric signal generated by the metal-BP thermocouple junctions is zero, because the thermocouple current is always driven from the low S_b material ($S_b \approx 0 \mu\text{V/K}$ for metals) to the high S_b material ($S_b \approx 100 \mu\text{V/K}$ for BP, ref.¹⁹) and the contributions from the S and D sides of the channel are equally compensated. Furthermore, it is worth mentioning that, although the Seebeck coefficient is isotropic, the temperature gradient is expected to change in BP-FET with the orientation of the flake, being the thermal conductivity strongly anisotropic and larger (of \approx a factor of 2.7, ref. 25) along the zig-zag axis;²⁶ iii) I_{pv} cannot be activated in our samples because the THz photons energy is much lower than the BP energy gap ($\approx 300 \text{ meV}$ for flakes thicker than 10 nm, ref. 13); iv) in the case of sample A, the asymmetric feeding of the radiation produces a not negligible temperature gradient across the FET channel. Thus, a strong thermoelectric response, caused by the induced diffusion currents, is expected within the BP flake. Due to the absence of a dc bias, the thermoelectric effect is expected to be strongly dominant with respect to the bolometric effect¹⁹. Conversely, the latter might play a non-negligible role in sample B, in which the radiation is symmetrically fed at the S-D electrodes; in this latter case the static voltage gradient $dV(x)/dx$ along the FET channel is provided by the different boundary conditions at the S (grounded) and D (open-circuit) FET sides.

In the case of a degenerate semiconductor, S_b can be expressed through the Mott equation¹⁸, which has the same functional dependence set by Eq. (1), therefore preventing to discriminate between the thermoelectric and the plasma-wave effects, when the channel architecture and device geometry allows both detection processes to be activated. However, the comparison between Δu and Δu^* provides a valuable way to unveil the dominant effect that is contributing to the detection.

Under the assumption that thermoelectric effects dominate in our device A, the THz-induced carrier distribution gradient generates a diffusive flux of holes from the *hot*-side (S) to the *cold*-side (D) of the channel, hence, under zero-bias operation, (positive) charges will be accumulated at D whose potential will rise from zero to a (positive) thermoelectric value Δu_{pe} . Conversely, if $V_{\text{SD}} \neq 0$ (with $V_{\text{D}} > V_{\text{S}}$ being S grounded) a certain amount of current will flow through the channel. If the sample is kept in the dark, the only electromotive force will be provided by the dc voltage V_{SD} , and $I_{\text{SD,off}}$ [Fig. 3(a)] will flow from D to S, i.e. in the opposite direction with respect to the light induced generated photothermoelectric current (I_{pe})¹⁸. Thus if $I_{\text{SD,off}} > 0$, $\Delta u^*_{\text{pe}} = (I_{\text{pe}} - I_{\text{SD,off}})/\sigma$ will be negative while $\Delta u_{\text{pe}} > 0$, in clear disagreement with our experimental data [Figs 3(c), 4(a)] where both Δu and Δu^* are positive.

On the other hand, if over-damped plasma-wave effects dominate in our device A, the excited carrier density would be pushed toward one channel side or the other depending on the structure asymmetry. In fact, at zero bias ($V_{\text{SD}} = 0 \text{ V}$), the sign of the plasma-wave photovoltage Δu_{pw} is not known a priori. However, the corresponding Δu^*_{pw} is well defined, since the applied dc voltage V_{DS} sets an asymmetric direction across the channel that will cause the charge density to drift towards the S side. The THz-induced current will then sum up with the pre-existent dc current, leading to $\Delta u^*_{\text{pw}} > 0$, in agreement with our experimental data [Fig. 3(c)].

These considerations support the conclusion that sample A behaves like a plasma-wave THz detector, operating in the non-resonant overdamped regime, being $\omega \mu m_d^* / e \ll 1$, where m_d^* is the hole effective mass²⁷ along the D-axis, e the electron charge and $\omega/2\pi = 0.29 \text{ THz}$ ²⁸, which in the present experimental case/geometry means $\nu \ll 0.85 \text{ THz}$.

The choice of a BP, D-axis oriented, flake is ideal to selectively activate the plasma-wave photodetection regime in sample A. The x-axis orientation, with its combined poor thermal conductivity and large electrical conductivity¹², is indeed expected to enhance the BP thermoelectric performance while still allowing the activation of plasma-wave effects. Instead, the y-axis orientation can significantly reduce the sensitivity performance of the plasma-wave detector due to the major increase in the channel resistance¹² (eq. 1).

The devised architecture allows the complete switching from a plasma-wave to a fully thermoelectric detection behavior. In the employed device configuration, the impedance matching between the device and the antenna is strongly frequency-dependent. Moreover, the generation of plasma-waves within the gated region requires a precise phase relation between the velocity and carrier density modulations for the rectification process to occur (see Methods). Therefore a slight change in frequency is in principle able to abruptly turn off the plasma-wave mediated THz detection. Figure 4e shows the photovoltage collected in sample A while detuning the frequency of the THz source (0.32 THz) from the antenna resonance (0.29 THz). In this latter case, the mechanism for light harvesting is not efficient enough to activate the oscillation and the mixing of the plasma-waves in the transistor channel. Therefore, the THz-induced thermal distribution gradient will generate a diffusive flux of holes from S to D, in opposite direction with respect to $I_{\text{SD,off}}$. This sign discrepancy well reflects in the comparison between Δu^* and the experimental responsivity curve [Fig. 4(e)].

To elucidate the nature of the detection process in sample B, we estimated the bolometric photovoltage (V_B), via its functional dependence¹⁹ from the ratio $\frac{1}{\sigma} \frac{d\sigma}{dT}$:

$$V_B = \frac{I_B}{\sigma} \propto \frac{\gamma}{\sigma} = \frac{1}{\sigma} \frac{d\sigma}{dT} \quad (3)$$

The trend reported in Fig. 4(d) is in excellent agreement with the experimental responsivity curve, thus confirming that device B behaves like a bolometer. Importantly, the responsivity curve in Fig. 4(b) shows a noticeable sign switch at $V_G = -1.1 \text{ V}$, in perfect coincidence with the sign switch of γ [Fig. 4(d)], likely due to the huge carrier density modulation induced by the gate voltage. Furthermore, the bolometric photodetection mechanism, based on a light-induced change in conductance, is here due to the unveiled temperature dependent carrier mobility change [Fig. 3(b)].

The choice of the y-orientation is ideal for the activation of an efficient, single and selective bolometric detection process. Firstly, this ensures to fully suppress thermoelectric-related phenomena (strongly enhanced along

the x -axis). More importantly, the longitudinal in-plane acoustic phonons show a sound speed (then a conductance) along the y -direction (8397 m/s) almost twice than the sound speed along the x -direction (4246 m/s). The thermal conductance is proportional to the squares of these sound speeds¹². Conversely, the out-of-plane acoustic mode (ZA), which governs the electron-lattice cooling, exhibits a parabolic dispersion in layered materials and a significantly lower conductance. Thus, while an efficient heat-transfer from the antenna to the BP-flake is provided by the large in-plane y -axis thermal conductance, the electron cooling by acoustic phonons is slowed by the less effective e -ZA phonon coupling. This increases the device thermal resistance, which defines the bolometric sensitivity.

The responsivity curve in Fig. 4(b) shows the expected bolometric detection trend; when the conductivity of the flake is rather high (negative V_G), the THz radiation is effectively absorbed, but the small relative change in absorption leads to a rather small responsivity; the highest responsivity is reached when the conduction of the flake is decreased and therewith the influence of the electron heating is maximized. When the conductivity is further decreased, the responsivity decreases again as the number of electrons available for intraband absorption is further decreased.

The background signal, measured while blanking the THz beam, is shown in Fig. 4(a) and Fig. 4(b) and allows extracting the signal-to-noise ratios (SNR): SNR \approx 500 for the plasma-wave detector (sample A) and SNR \approx 100 for the bolometric detector (sample B). By switching to a fully thermoelectric detection the SNR of sample A decreases to SNR \approx 90. Remarkably, maximum R_v of 5.0 V/W and 7.8 V/W have been reached for sample A and sample B, respectively, significantly larger than those reported in exfoliated graphene FETs^{22,29}. The responsivity reduces to 1.1 V/W when device A operates in the thermoelectric regime. Under the assumption that the detector noise figure is dominated by the thermal Johnson-Nyquist contribution $N_{th} = (4k_B T/\sigma)^{1/2}$, we can infer the noise-equivalent power (NEP) i.e. the lowest detectable power in a 1 Hz bandwidth that can be calculated as N_{th}/R_v ³⁰. Figure 4(f) shows the extrapolated NEP curves, whose minimum reaches 7 nW/ $\sqrt{\text{Hz}}$, 10 nW/ $\sqrt{\text{Hz}}$ and 45 nW/ $\sqrt{\text{Hz}}$ for the BP-bolometer, plasma-wave and thermoelectric detector, respectively.

The remarkable SNR of the plasma-wave detector (sample A) has been exploited to provide concrete application examples of the devised detection technology, in a set of transmission imaging experiments. The 0.29 THz beam was focused on the target object and the transmitted power was detected in photovoltage configuration while keeping $V_G = -0.4$ V. The 400×700 pixel image of a set of target objects was acquired with a time constant of 10 ms. The THz scans are shown in Fig. 5(a,c) together with the correspondent photographs of the target objects. The transmission images [Fig. 5(a)] of a set of two tablets before (left side) and after (right side) injecting $3 \mu\text{l}$ of water in one of them, show that the BP detector clearly reveals the humidity-induced tablet deterioration, with the anomalous water content. Figure 5(c) shows the transmission image of a chocolate bar with some residue of the aluminum external package, clearly resolved by the BP detectors.

The versatility provided by the BP anisotropy and its tunable band gap unveils the potential of such material for optoelectronic and photonic devices with fully switchable response and performances, promising exceptional impact of few-layer phosphorene for devising active and passive THz devices and components.

Methods

Growth, material characterization and device fabrication. The BP single crystal was synthesized using a chemical vapor transport method²⁰. The evacuated quartz tube containing red phosphorus has been placed into a double-zone tube furnace with temperatures set at 600 °C and 500 °C for the hot and cold end, respectively. Large-size single crystals of BP can be obtained after a week of transport.

The AFM mapping has been performed by employing a Bruker system (IconAFM) with thickness resolution < 1 nm and lateral resolution ~ 20 nm. Each flake shows a layer thickness integer multiple of ~ 0.61 nm, i.e. the thickness of a BP monolayer (phosphorene).

Micro-Raman spectra have been collected by exciting the BP flakes of sample A and B along the z axis, by employing a Renishaw (InVia) system, equipped with a frequency doubled Nd:Yag 532 nm laser having maximum output power of 500 mW (CW). In the present experiments, we kept the optical intensity ≤ 0.4 mW/ μm^2 , since intensity values larger than 0.8 mW/ μm^2 are likely to damage the flakes.

Thin flakes ($h \sim 9$ – 15 nm) were individually contacted via a combination of electron beam lithography (EBL) and thermal evaporation to deposit the (10/70 nm) (Ni/Au) S and D metal contacts. A 65 nm thick SiO₂ oxide layer was then deposited on the sample via Ar sputtering, so that the exposed face of the BP-flake is fully encapsulated with it. This is a crucial step to prevent degradation due to ambient air humidity, that, conventionally, dramatically alter the electrical device performances and deteriorate the flake itself. The G electrode was aligned with the center of the channel via EBL and defined via thermal evaporation of 80 nm layer of Cr/Au. Sample A and B are equipped with antisymmetric (A) and symmetric (B) bow-tie antennas with radius $r_A = 500 \mu\text{m}$ and $r_B = 250 \mu\text{m}$, respectively. For sample A, the channel length is $L = 1.8 \mu\text{m}$ and the gate length is $L_G = 1.0 \mu\text{m}$ while for sample B, $L = 900$ nm and $L_G = 450$ nm. Under this configuration, and in the presence of a 65 nm thick oxide layer, the simulated (3D FEM, COMSOL Multiphysics) geometrical gate-to-channel capacitance are $C_{gc} \sim 1.44$ fF and $C_{gc} = 0.39$ fF for samples A and B, respectively.

Top-gate Capacitance estimation. For a thin layer channel, the top-gate capacitance (C_{TG}) is usually expressed as:

$$C_{TG} = \left(\frac{1}{C_{gc}} + \frac{1}{C_t + C_q} \right)^{-1} \quad (4)$$

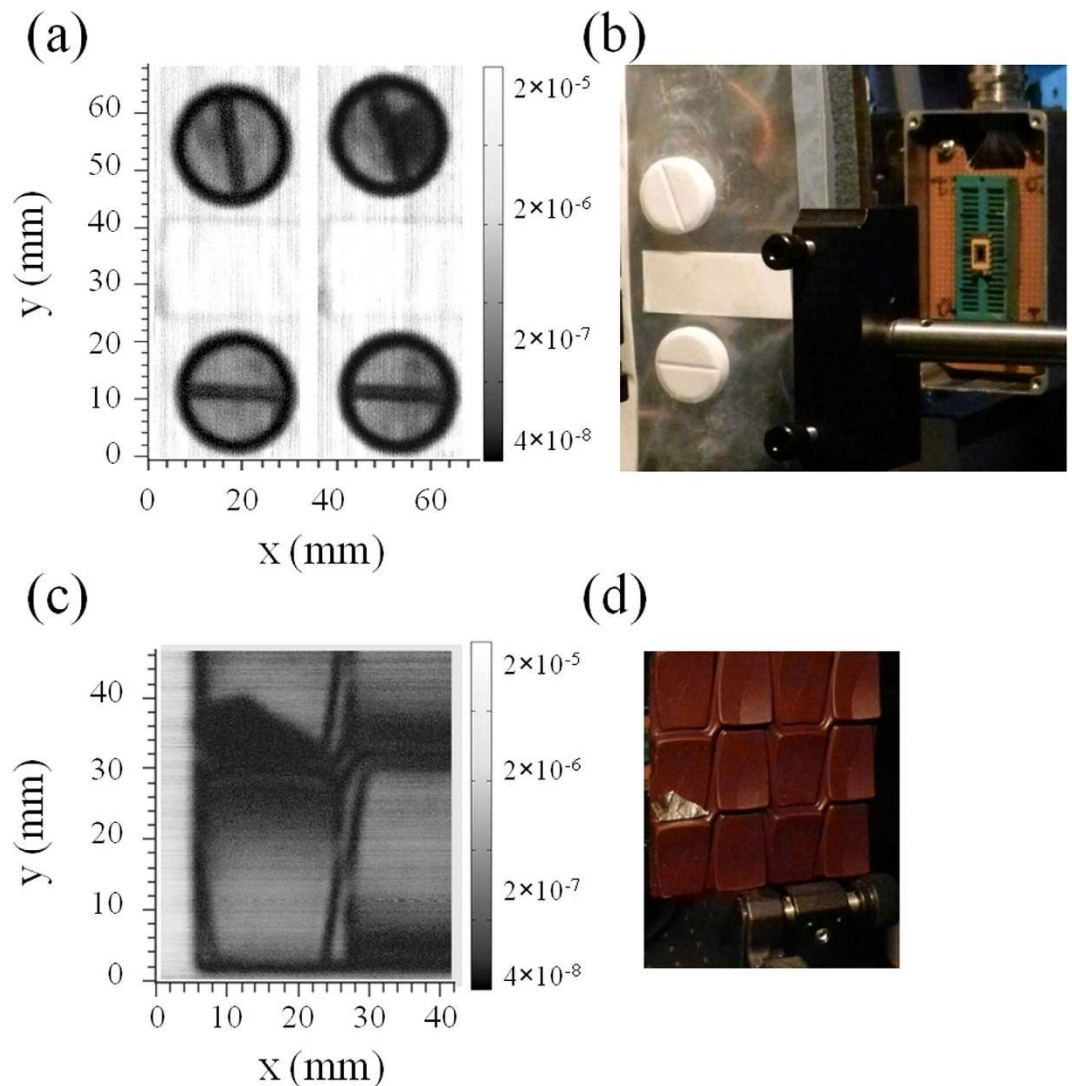


Figure 5. Large-area, fast, transmission THz imaging. (a) RT, transmission THz imaging obtained while impinging the 0.29 THz radiation on a box of two tablets before (left) and after (right) injecting $3 \mu\text{l}$ of water in one of them mounted on a XY stage, with an acquisition time of 10 ms/pixel. For visible light illumination the humidity-induced tablet deterioration, with the anomalous water content cannot be seen, either by naked eye or by the CCD camera used to take the related photograph (b). The detection of THz transmitted radiation provides a visible signature on that. (c) RT, transmission THz imaging obtained while impinging the 0.29 THz radiation on a chocolate bar mounted on a XY stage, with an acquisition time of 10 ms/pixel. The residue of the aluminum external package is clearly resolved by the detectors. (d) Photograph of the chocolate bar collected from its rear side.

A significant portion of the electrostatic gate potential (V_G) is dropped within the oxide to fill trap states (and interface states) and inside the channel to modify the carrier population. These two effects are typically modeled by introducing the interface trap capacitance (C_t) and the quantum capacitance (C_q). An estimation of the ratio C_t/C_{gc} can be obtained from the subthreshold swing (S_s) of the FET. S_s is conventionally expressed in terms of the band movement factor: $\beta = [1 + (C_t + C_q)/C_{gc}]$.¹² In the subthreshold regime, the channel is almost depleted of free carriers, hence C_q can be safely neglected, the channel bands move one-to-one with the applied gate bias. The logarithmic plot of the transconductance curve shows a linear region whose slope corresponds to the subthreshold slope (S_s)⁻¹. Being $S_s \sim 60 \beta$ mV/dec, the linear fit to the data allows to retrieve $S_s = 238$ mV/dec and $S_s = 1136$ mV/dec, corresponding to $\beta = 4$ ($C_t = 3 C_{gc}$) for sample A and $\beta = 19$, ($C_t = 18 C_{gc}$) for sample B, respectively. The larger β value in sample B is fully consistent with the expected quantum capacitance increase in the thicker BP flake. By increasing V_G , C_{TG} varies in the range $[0.75 C_{gc}, C_{gc}]$ for sample A and in the range $[0.95 C_{gc}, C_{gc}]$ for sample B.

Optical characterization. The optical characterization has been performed by focusing the THz frequency beam on a spot of 4 mm diameter at the detector surface by means of a set of $f/1$ off axis parabolic mirrors and

mechanically chopped at 619 Hz. The power of the source (P_t), calibrated as a function of output frequency with a power meter, ranges between $200\ \mu\text{W}$ and $400\ \mu\text{W}$. The responsivity was measured in a photovoltage-mode (PV) configuration: the S electrode was grounded, V_G was set with a Keithley *dc* generator and Δu was measured at the D electrode with a lock-in amplifier. A low-noise voltage pre-amplifier (input impedance = $10\ \text{M}\Omega$) with a pass-band filter between 300 Hz and 1 kHz was used in the experiments with a gain factor $G_n = 1000$. From this voltage measurement Δu can be calculated using the equation³⁰:

$$\Delta u = \frac{\sqrt{2} \frac{\pi}{2} \cdot LIA}{G_n} \quad (5)$$

where *LIA* is the voltage read by the lock-in, and the factor $\pi\sqrt{2}/2$ is a normalization coefficient that takes into account that the lock-in measures the rms of the fundamental sine wave Fourier component of the square wave produced by the chopper. We preventively measure Δu as a function of frequency by employing the tunable source to identify the antenna resonances for sample A and B, that in both cases coincides with $\nu = 298.5\ \text{GHz}$ ($P_t = 300\ \mu\text{W}$). The intensity peak at $\nu_1 = 324.6\ \text{GHz}$ ($P_t = 400\ \mu\text{W}$) provides a 70% response reduction. The responsivity (R_v) was then determined using the relation $R_v = (\Delta u \cdot S_t)/(P_t \cdot S_a)$, where S_t is the beam spot area and S_a is the active area of the detector; in the case of sample A, S_a is set equal to the diffraction limited area ($S_\lambda = \lambda^2/4$), being the antenna surface smaller than S_λ ³⁰.

The total efficiency of the receiving antenna (η) can be approximated as the product of the collection efficiency ϵ_{coll} , which represents the capability to collect a photon, and the mismatch efficiency ϵ_{match} , which refers to the impedance matching between the antenna and the connected electrical circuit, i.e. as: $\eta = \epsilon_{\text{coll}} \times \epsilon_{\text{match}}$, where

$$\epsilon_{\text{match}} = 1 - |\Gamma|^2 = 1 - \left| \frac{Z_{\text{antenna}} - Z_{\text{circuit}}^*}{Z_{\text{antenna}} + Z_{\text{circuit}}} \right|^2 \quad (6)$$

Here, Γ is the reflection coefficient and Z_{antenna} , Z_{circuit} represent the complex antenna and connected circuit impedances, respectively. When the antenna is operating at its resonance frequency, the imaginary part of Z_{antenna} drops to zero. ϵ_{match} is then a function of frequency and channel resistance (then gate voltage) in our experiments.

The minimum measured resistance of the BP flake is $20\ \text{k}\Omega$, whereas the impedance of a planar bow-tie antenna is conventionally $70\ \Omega - 100\ \Omega$. Since in the case of a S-G antenna there is only a capacitive coupling between the circuit and the antenna, we can extract the capacitances and inductances playing a role in the FETs and then evaluate the complex impedance matching, which determines the electromagnetic power delivered to the BP flake. In the case of sample A, the maximum $\epsilon_{\text{match}} = 0.11$, meaning that only 11% of the power collected by the antenna is delivered to the BP flake.

To assess the THz-induced photocurrent $I_{\text{SD,on}}$ we exploited a photoconductive scheme: a *dc* bias (V_{SD}) is applied to the source electrode and the current is read at the D electrode with an amperometer while shining the THz radiation on the detector.

References

- Ferrari, A. C. *et al.* Science and technology roadmap for graphene, related two-dimensional crystals and hybrid systems. *Nanoscale* **7**, 4598–4810 (2015).
- Britnell, L. *et al.* Strong Light-Matter interactions in Heterostructures of Atomically Thin Films. *Science* **340**, 1311–1314 (2013).
- Youngblood, N. Chen, C., Koester, S. J. & Li, M. Waveguide-integrated black phosphorus photodetector with high responsivity and low dark current. *Nature Photonics* **9**, 247–252 (2015).
- Liu, M. *et al.* A graphene-based broadband optical modulator. *Nature* **474**, 64–67 (2011).
- Pesin, D. & Mac Donald, A. H. Spintronics and pseudospintronics in graphene and topological insulators. *Nature Materials* **11**, 409–416 (2012).
- Rumyantsev, S. *et al.* Selective Gas Sensing with a Single Pristine Graphene Transistor. *Nano Lett.* **12**, 2294–2298 (2012).
- Koppens, F. H. L. *et al.* Photodetectors based on graphene, other two-dimensional materials and hybrid system. *Nature Nanotech.* **9**, 780–793 (2014).
- Liu, N. *et al.* Large-Area, Transparent, and Flexible Infrared Photodetector Fabricated Using P-N Junctions Formed by N-Doping Chemical Vapor Deposition Grown Graphene. *Nano Lett.* **14**, 3702–3708 (2014).
- Tredicucci, A. & Vitiello, M. S. Device concepts for graphene based Terahertz photonics. *IEEE Journal of Selected Topics in Quantum electronics* **20**, 8500109 (2014).
- Wang, Q. H. *et al.* Electronics and optoelectronics of two-dimensional transition metal dichalcogenides. *Nature Nanotechnology* **7**, 699–712 (2012).
- Engel, M., Steiner, M. & Avouris, P. Black Phosphorus Photodetector for Multispectral, High-Resolution Imaging. *Nano Lett.* **14**, 6414–6417 (2014).
- Das, S. *et al.* Tunable Transport Gap in Phosphorene. *Nano Lett.* **14**, 5733–5739 (2014).
- Xia, F., Wang, H. & Jia, Y. Rediscovering black phosphorus as an anisotropic layered material for optoelectronics and electronic. *Nature Comm.* **5**, 4458 (2014).
- Ge, S. *et al.* Dynamical Evolution of Anisotropic Response in Black Phosphorus under Ultrafast Photoexcitation. *Nano Lett.* **15**, 4650–4656 (2015).
- Hong, T. *et al.* Polarized photocurrent response in black phosphorus field-effect transistors. *Nanoscale* **6**, 8978–8983 (2014).
- Buscema, M. *et al.* Photovoltaic effect in few-layer black phosphorus PN junctions defined by local electrostatic gating. *Nature Comm.* **5**, 4651 (2014).
- Yuan, H. *et al.* Polarization-sensitive broadband photodetector using a black phosphorus vertical p-n junction. *Nature Nanotechnology* **10**, 707–713 (2015).
- Viti, L. *et al.* Black-phosphorus Terahertz photodetectors *Advanced Materials* **27**, 5567–5572 (2015).
- Low, T. Engel, M., Steiner, M. & Avouris, P. Origin of photoresponse in black phosphorus phototransistor. *Phys. Rev. B* **90**, 081408 (2014).
- Gillgren, N. *et al.* Gate tunable quantum oscillations in air-stable and high mobility few-layer phosphorene heterostructures. *2D Materials* **2**, 011001 (2015).

21. Dyakonov, M. & Shur, M. Detection, Mixing, and Frequency Multiplication of Terahertz Radiation by Two-Dimensional Electronic Fluid. *IEEE Trans. on Electron Dev.* **43**, 3 (1996).
22. Vicarelli, L. *et al.* Graphene field-effect transistors as room-temperature terahertz detectors, *Nature Materials* **11**, 865 (2012).
23. Zak, A. *et al.* Antenna-Integrated 0.6 THz FET Direct Detectors Based on CVD Graphene. *Nano Lett.* **14**, 5834–5838 (2014).
24. Sakowicz, M. *et al.* Terahertz responsivity of field-effect-transistors versus their static channel conductivity and loading effects. *J. Appl. Phys.* **110**, 054512 (2011).
25. Jain, A. & McGaughey, A. J. H. Strongly anisotropic in-plane thermal transport in single-layer black phosphorene. *Scientific Rep.* **5**, 8501 (2015).
26. Fei, R. *et al.* Enhanced Thermoelectric Efficiency via Orthogonal Electrical and Thermal Conductances in Phosphorene. *Nano Lett.* **14**, 6393–6399 (2014).
27. Cai, Y., Zhang, G. & Zhang, Y.-W. Layer-dependent Band Alignment and Work Function of Few-Layer Phosphorene. *Scientific Rep.* **4**, 6677 (2014).
28. Knap, W. & Dyakonov, M. I. Field effect transistors for terahertz applications. In *Handbook of terahertz technology for imaging, sensing and communications*, Cambridge, Woodhead Publishing, 121–155 (2013).
29. Spirito, D. *et al.* High performance bilayer-graphene terahertz detectors. *Appl. Phys. Lett.* **104**, 061111 (2014).
30. Vitiello, M. S. *et al.* Room-Temperature Terahertz Detectors Based on Semiconductor Nanowire Field-Effect Transistors. *Nano Lett.* **12**, 96–101 (2012).

Acknowledgements

The authors acknowledge support from the European Union Seventh Framework Programme grant agreement n° 604391 Graphene Flagship, the Italian Ministry of Education, University, and Research (MIUR) through the program “FIRB - Futuro in Ricerca 2010 RBFR10LULP “Fundamental research on Terahertz photonic devices”, the European Union through the MPNS COST Action “MP1204 TERA-MIR Radiation: Materials, Generation, Detection and Applications”, the ANR P2N NADIA “Integrated NANO-Detectors for terahertz Applications” (ANR-13-NANO-0008), the National Science Poland Centre (DEC-2013/10/M/ST3/00705), the NSF/LA-SiGMA program under award #EPS-1003897. AP and JH thank Z. Mao for helpful discussions. MSV acknowledge A. Tredicucci for critical and fruitful discussions.

Author Contributions

M.S.V. conceived and devised the experiments; L.V. fabricated the devices; J.H. performed the material growth; L.V., D.C. and M.S.V. performed the measurements; L.V. and M.S.V. analyzed and modeled the data; M.S.V. wrote the manuscript and coordinated the project. W.K. and A.P. contributed to the scientific discussion of the results at various stages.

Additional Information

Competing financial interests: The authors declare no competing financial interests.

How to cite this article: Viti, L. *et al.* Efficient Terahertz detection in black-phosphorus nano-transistors with selective and controllable plasma-wave, bolometric and thermoelectric response. *Sci. Rep.* **6**, 20474; doi: 10.1038/srep20474 (2016).



This work is licensed under a Creative Commons Attribution 4.0 International License. The images or other third party material in this article are included in the article’s Creative Commons license, unless indicated otherwise in the credit line; if the material is not included under the Creative Commons license, users will need to obtain permission from the license holder to reproduce the material. To view a copy of this license, visit <http://creativecommons.org/licenses/by/4.0/>